

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q84137

Shinichi ISHIBASHI, et al.

Appln. No.: National Stage Entry of PCT/JP03/04615

Confirmation No.: Not yet assigned

Group Art Unit: Not yet assigned

Filed: October 12, 2004

Examiner: Not yet assigned

For: **REFLECTIVE MASK BLANK, REFLECTIVE MASK AND METHODS OF
PRODUCING THE MASK BLANK AND THE MASK****PRELIMINARY AMENDMENT****MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Prior to examination, please amend the above-identified application as follows on the accompanying pages.

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